

In re application of

Confirmation No. 1862

Taku HIRAYAMA et al.

Attorney Docket No. 2005 0892A

Serial No. 10/537,290

: Group Art Unit 1752

Filed June 1, 2005

Examiner Sin J. Lee

CHEMICAL-AMPLIFICATION TYPE SILICONE-BASED POSITIVE-WORKING PHOTORESIST COMPOSITION MAIL STOP: AMENDMENT

**AMENDMENT** 

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO 23-0975

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 3, 2007, the period for response having been extended for one month by the attached Petition, please amend the present application as follows: